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Canon ANELVA Corporation



JIS Q 9001:2015 (ISO 9001:2015)

Issue 13

Sites

Canon ANELVA Corporation Head Office 2-5-1 Kurigi, Asao-ku, Kawasaki-shi, Kanagawa Japan

1.DESIGN, DEVELOPMENT, MANUFACTURE, SALES, MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT 2.DESIGN, DEVELOPMENT, MANUFACTURE, SALES, MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF VACUUM RELEVANT EQUIPMENT

Canon ANELVA Corporation Fuji Plant 8532-28 Narusawa-mura, Minamitsuru-qun, Yamanashi Japan

1.DESIGN, DEVELOPMENT, MANUFACTURE, MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT 2.DESIGN, DEVELOPMENT, MANUFACTURE, MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF VACUUM RELEVANT EQUIPMENT

Canon ANELVA Corporation West Japan Sales/West Japan Service Chuosha Bldg. 2-14-35 Minamikaneden, Suita-shi, Osaka Japan

1.SALES, MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT

2.SALES, MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF VACUUM RELEVANT EQUIPMENT





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Canon ANELVA Corporation Kyusyu Sales/Kyusyu Service

Canon MJ Kumamoto Bldg., 3-3-10 Obiyama, Chuo-ku, Kumamoto-shi, Kumamoto Japan

1.SALES, MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT

2.SALES, MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF VACUUM RELEVANT EQUIPMENT

Canon ANELVA Corporation

Tohoku Service

3-3-15 lwakiribundai, Miyagino-ku, Sendai-shi, Miyagi Japan

1.MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT

2.MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF VACUUM RELEVANT EQUIPMENT

Canon ANELVA Corporation

Nagano Service

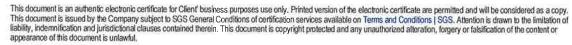
1-1 Daimon-namikicho, Shiojiri-shi, Nagano Japan

1.MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT

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Canon ANELVA Corporation Kanazawa Service 1-54 Seito, Kanazawa-shi, Ishikawa Japan

1.MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT

2.MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF VACUUM RELEVANT EQUIPMENT

Canon ANELVA Corporation Hiroshima Service 6-17-5 Miyaura, Mihara-shi, Hiroshima Japan

1.MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT

2.MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF VACUUM RELEVANT EQUIPMENT

Canon ANELVA Corporation Shikoku Service 2-37 Okihama, Tokushima-shi, Tokushima Japan

1.MODIFICATION MANAGEMENT AND MAINTENANCE SERVICING MANAGEMENT OF: SEMICONDUCTOR MANUFACTURE EQUIPMENT, STORAGE DEVICE MANUFACTURE EQUIPMENT, PANEL DEVICE MANUFACTURE EQUIPMENT, THIN FILM DEPOSITION EQUIPMENT FOR R&D, VACUUM COMPONENTS, GAS ANALYTICAL EQUIPMENT, SURFACE ANALYTICAL EQUIPMENT

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